







PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q85485

Satoshi KITAZAWA, et al.

Appln. No.: 10/541,234

Group Art Unit: 1773

Confirmation No.: 4040

Examiner: CHEN, VIVIAN

Filed: July 01, 2005

For:

ANTISTATIC LAMINATED POLYESTER FILM

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.97 and 1.98

MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form and/or listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application.

One copy of each of the listed documents is submitted herewith, along with a copy of the corresponding Communication from a Foreign Patent Office, except for the following: U.S. patents and/or U.S. patent publications; and co-pending non-provisional U.S. applications filed after June 30, 2003.

The present Information Disclosure Statement is being filed: (1) No later than three months from the application's filing date; (2) Before the mailing date of the first Office Action

INFORMATION DISCLOSURE STATEMENT

U.S. Appln. No.: 10/541,234

on the merits (whichever is later); or (3) Before the mailing date of the first Office Action after

filing a request for continued examination (RCE) under §1.114, and therefore, no Statement

under 37 C.F.R. § 1.97(e) or fee under 37 C.F.R. § 1.17(p) is required.

The present Information Disclosure Statement is being filed thirty days or fewer from the

communication from a foreign patent office and a Statement Under 37 C.F.R. §1.704(d) is

attached.

The submission of the listed documents is not intended as an admission that any such

document constitutes prior art against the claims of the present application. Applicant does not

waive any right to take any action that would be appropriate to antedate or otherwise remove any

listed document as a competent reference against the claims of the present application.

The USPTO is directed and authorized to charge all required fees, except for the Issue

Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any

overpayments to said Deposit Account.

Respectfully submitted,

Registration No. 24,513

Peter D. Olexy

SUGHRUE MION, PLLC

Telephone: (202) 293-7060

Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373 CUSTOMER NUMBER

Date: March 10, 2006

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STATEMENT UNDER 37 C.F.R. § 1.704(d)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

For:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was cited in a communication from a foreign patent office in a counterpart foreign application, and that the communication was not received by any individual designated in 37 C.F.R. § 1.56(c) more than thirty days prior to the filing of said Information Disclosure Statement.

Respectfully submitted,

Peter D. Olexy

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Facsimile: (202) 293-7860

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Substitute for Form 1449 A & B/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

	WODII IED I TO/SB/00 X & B (00-05)			
Complete if Known				
Application Number	10/541,234			
Confirmation Number	4040			
Filing Date	July 01, 2005			
First Named Inventor	Satoshi KITAZAWA			
Art Unit	1773			
Examiner Name	CHEN, VIVIAN			
Attorney Docket Number	Q85485			

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MAR 1	O FARR S		U.S. 1	PATENT DOCU	IENTS	
Examiner	Cite	Document Number		Publication Date		
Initials*	No.	Number	Kind Code ² (if known)	MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	
W 8	HAD	US 5,281,472	Α	01-25-1994	Takahashi et al.	
		US 5,453,326	Α	09-26-1995	Siddiqui, et al.	
		US 6,469,092	Bl	10-22-2002	Stoppelmann et al.	
		US 5,306,606	Α	04-26-1994	Tachibana et al	
		US				
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		US				
		US				
		US				

FOREIGN PATENT DOCUMENTS							
Cite No.1	Foreign Patent Document			Publication Date	Name of Patentee or		
	Country Code ³	Number ⁴	Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation ⁶	
	EP	0 637 603	A1	02-08-1995	ICI Americas Inc.	English	
	wo	94/13477	A1	06-23-1994	Hoechst Aktiengesellschaft; Hoechst Celanese Corporation; Bennett, Cyn	English	
	EP	0 570 795	A1	11-24-1993	Agfa-Gevaert AG	No	
	EP	0 445 744	A2	09-11-1991	Diafoil Company Limited	English	
	EP	0 435 080	A1	07-03-1991	Teijin Limited	English	
	ЕР	0 366 483	A2	05-02-1990	Minnesota Mining and Manufacturing Company	English	
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		Country Code ³ EP WO EP EP EP	Cite No.1 Foreign Patent Docu Country Code3 Number4 EP 0 637 603 WO 94/13477 EP 0 570 795 EP 0 445 744 EP 0 435 080	Cite No.¹ Foreign Patent Document Country Code³ Number⁴ Kind Code⁵ (if known) EP 0 637 603 A1 WO 94/13477 A1 EP 0 570 795 A1 EP 0 445 744 A2 EP 0 435 080 A1	Cite No.¹ Foreign Patent Document Publication Date MM-DD-YYYY Country Code³ Number⁴ Kind Code⁵ (if known) EP 0 637 603 A1 02-08-1995 WO 94/13477 A1 06-23-1994 EP 0 570 795 A1 11-24-1993 EP 0 445 744 A2 09-11-1991 EP 0 435 080 A1 07-03-1991	Cite No.¹ Foreign Patent Document Publication Date MM-DD-YYYY Name of Patentee or Applicant of Cited Document EP 0 637 603 A1 02-08-1995 ICI Americas Inc. WO 94/13477 A1 06-23-1994 Hoechst Aktiengesellschaft; Hoechst Celanese Corporation; Bennett, Cyn EP 0 570 795 A1 11-24-1993 Agfa-Gevaert AG EP 0 445 744 A2 09-11-1991 Diafoil Company Limited EP 0 435 080 A1 07-03-1991 Teijin Limited ED 0 266 482 A2 05 02 1000 Minnesota Mining and	

	NON PATENT LITERATURE DOCUMENTS				
Examiner Cite Initials* No.1		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published			
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Examiner Signature	 Date Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.



<u>FILING RECEIPT</u> PLEASE DATE STAMP AND RETURN TO US - BOX 235X

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PAPER(S) FILED ENTITLED:

1. Information Disclosure Statement (with a copy of Communication from a foreign patent office, references and PTO/SB/08 A & B (modified))

2. Statement Under 37 C.F.R. § 1.97(e)

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SUGHRUE MION, PLLC

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